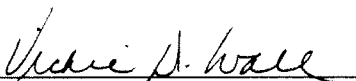


PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being electronically filed with the United States Patent and Trademark Office on July 16, 2007 at or before 11:59 p.m. Pacific Time under the Rules of 37 CFR § 1.8.


Vickie D. Wall

Applicant : Nam Hun Kim Confirmation No. 5813
Application No. : 10/593,857
Filed : September 22, 2006
Title : PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND
METHOD FOR ETCHING THE WAFER USING THE SAME

Grp./Div. : 1763
Examiner : To be assigned

Docket No. : 58409/N305

LETTER TO CORRECT FILING RECEIPT

Office of Initial Patent Examination's
Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
July 16, 2007

Commissioner:

When proofing the Filing Receipt for the above-identified application, we located the following error:

Under Foreign Applications:


Please delete "GERMANY" and enter --KOREA-- as indicated on the enclosed Declaration and Power of Attorney filed September 22, 2006. A copy of the Filing Receipt indicating the necessary correction is also enclosed.

Application No. 10/593,857

Please forward a Corrected Filing Receipt to the undersigned.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

A handwritten signature in cursive script that reads "D. Bruce Prout".

By _____

D. Bruce Prout
Reg. No. 20,958
626/795-9900

DBP/vdw

Enclosure: Copy of Filing Receipt
Copy of Declaration

VDW PAS743967.1-* -07/16/07 9:15 AM



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APPL NO.	FILING OR 371(c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLMS	IND CLMS
10/593,857	09/22/2006	1763	550	58409/N305	12	4

CONFIRMATION NO. 5813

23363
CHRISTIE, PARKER & HALE, LLP
PO BOX 7068
PASADENA, CA 91109-7068

RECEIVED**JUN 22 2007****Christie, Parker & Hale, LLP**

FILING RECEIPT



OC000000024405421

Date Mailed: 06/19/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Nam Hun Kim, Suwon-si, KOREA, REPUBLIC OF;

Power of Attorney: The patent practitioners associated with Customer Number 23363.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/KR05/00860 03/24/2005

Foreign Applications

Korea
GERMANY 10-2004-0020321 03/25/2004

N305:
58409
CASE # _____
REMINDER _____

If Required, Foreign Filing License Granted: 06/18/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/593,857**

Projected Publication Date: 09/27/2007

Non-Publication Request: No

Early Publication Request: No

** SMALL ENTITY **

Title

Plasma Chamber Having Plasma Source Coil and Method for Etching the Wafer Using the Same

Preliminary Class

156

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Rev. 11/00

**DECLARATION AND POWER OF ATTORNEY
FOR PATENT APPLICATION**

PATENT

Docket No. : 58409.N305

As a below named inventor, I hereby declare that:

My residence, mailing address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND METHOD FOR ETCHING THE WAFER USING THE SAME, the specification of which is attached hereto unless the following is checked:

X was filed on March 24, 2005 as United States Application Number or PCT International Application Number PCT/KR2005/000860 and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment specifically referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR ? 1.56, including for continuation-in-part applications, material information which became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

I hereby claim foreign priority benefits under 35 U.S.C. ? 119(a)-(d) or ? 365(b) of the foreign application(s) for patent or inventor's certificate, or ? 365(a) of any PCT International application which designated at least one country other than the United States of America, listed below and have also identified below, any foreign application for patent or inventor's certificate, or any PCT International application having a filing date before that of the application on which priority is claimed.

Prior Foreign Application(s)

<u>Application Number</u>	<u>Country</u>	<u>Filing Date (day/month/year)</u>	<u>Priority Claimed</u>
10-2004-0020321	KOREA	25 March 2004	YES

I hereby claim the benefit under 35 U.S.C. ? 119(e) of any United States provisional application(s) listed below.

<u>Application Number</u>	<u>Filing Date</u>
---------------------------	--------------------

I hereby claim the benefit under 35 U.S.C. ? 120 of any United States application(s), or any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT International application in the manner provided by the first paragraph of 35 U.S.C. ? 112, I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR ? 1.56 which became available between the filing date of the prior application and the national or PCT International filing date of this application.

<u>Application Number</u>	<u>Filing Date</u>	<u>Patented/Pending/Abandoned</u>
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DECLARATION FOR PATENT APPLICATION

Docket No. 58409/N305

POWER OF ATTORNEY: I hereby appoint the practitioners associated with the law firm of Christie, Parker & Hale, LLP,

CUSTOMER NUMBER 23363

to prosecute this application and any U.S. continuation or divisional application based on it, and to prosecute any international application under the Patent Cooperation Treaty based on it, and to transact all business in the U.S. Patent and Trademark Office connected with either of them in accordance with instructions from the assignee of the entire interest in this application; or from the first or sole inventor named below in the event the application is not assigned; or from AJU INTERNATIONAL LAW & PATENT GROUP in the event the power granted herein is for an application filed on behalf of a foreign attorney or agent.

The authority under this Power of Attorney of each person associated with the law firm of Christie, Parker & Hale, LLP, Customer Number 23363, shall automatically terminate and be revoked upon such person ceasing to be a member or associate of or of counsel to that law firm.

DIRECT ALL CORRESPONDENCE TO: CUSTOMER NUMBER 23363


DIRECT TELEPHONE CALLS TO: D. Bruce Prout, 626/795-9900

CHRISTIE, PARKER & HALE, LLP

P.O. Box 7068

Pasadena, CA 91109-7068

I declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

NAME OF SOLE OR FIRST INVENTOR			
Nam Hun Kim			
Inventor's Signature 			Date Sep 15
Residence:	City Suwon-si	State	Country Republic of Korea
			Citizenship Korean
Mailing Address:	804-302 Byeokjeokgol Dusan Apt., 973-3 Yeongtong-dong, Paldal-gu, Suwon-si, Gyeonggi-do 442-470, Republic of Korea		

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